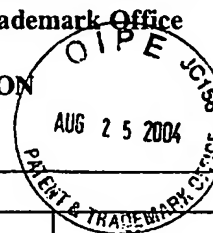


Form PTO-1449		U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No. 2271/71521	Serial No. 10/758,398	
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Applicants: <b>Takuro SEKIYA</b>		
				Filing Date: <b>January 15, 2004</b>		
				Group Art Unit:		
<b>U.S. PATENT DOCUMENTS</b>						
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
SIC	3 2 9 8 0 3 0	1/10/67	Lewis et al.			
	3 5 9 6 2 7 5	7/27/71	Sweet			
	3 6 8 3 2 1 2	8/8/72	Zoltan			
	3 7 4 7 1 2 0	7/17/73	Semme			
	3 9 4 6 3 9 8	3/23/76	Kyser et al.			
	4 5 0 4 8 4 4	3/12/85	Ebi et al.			
	4 5 1 0 5 0 9	4/9/85	Horike et al.			
	4 6 3 1 5 5 3	12/23/86	Sekiya			
	4 9 9 0 9 3 9	2/5/91	Sekiya et al.			
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SIC	5 8 7 7 7 8 6	3/2/99	Sekiya et al.			
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	Document Number	Date	Country	Class	Subclass	Translation
						Yes      No
SIC	JP 54-51837	4/24/1979	Japan			Abstract
	JP 2000-126681	5/9/2000	Japan			Abstract
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SIC	JP 2002-134878	5/10/2002	Japan			Abstract
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
7	"Cadmium Sulfide of Small Dimensions Produced in Inverted Micelles", Lianos, P. et al., Chemical Physics Letters, Vol. 125 No. 3, 1986. 12/86					
8	"Epitaxial Growth of Highly Luminescent CdSe/CdS Core/Shell Nanocrystals with Photostability and Electronic Accessibility", Peng, X. et al., J. Am. Chem. Soc., 119/1997.					
<b>EXAMINER</b> S. Kastler		<b>DATE CONSIDERED</b> 11/06				
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

<b>Form PTO-1449</b>		<b>U.S. Department of Commerce Patent and Trademark Office</b>		Atty. Docket No. <b>2271/71521</b>	Serial No. <b>10/758,398</b>
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Applicants: <b>Takuro SEKIYA</b>	
				Filing Date: <b>January 15, 2004</b>	Group Art Unit:



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FOREIGN PATENT DOCUMENTS								
Document Number	Date	Country	Class	Subclass	Translation			
					Yes	No		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

EXAMINER <b>S. Kasher</b>	DATE CONSIDERED <b>11/06</b>
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